



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	
	••)	Docket No. LAM2P298
Linda BRALY et al.)	
)	Examiner: W. Powell
Application No. 10/002,676)	
)	Group Art Unit: 1765
Filed:	October 31, 2001)	
)	Date: January 8, 2004
For:	METHOD FOR PLANARIZATION)	•
	ETCH WITH IN-SITU MONITORING)	
	BY INTERFEROMETRY PRIOR TO)	
	RECESS ETCH)	
		Ś	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 8, 2004.

Signed:

Diane Schwanbeck

AMENDMENT UNDER 37 C.F.R. § 1.312

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.312, please amend this application as follows:

The Amendments to the Claims made herein are reflected in the Listing of Claims, which begins on page 2 of this paper.

Applicants' Remarks begin on page 9 of this paper.